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[54] **METHOD OF MAKING BIFOCAL LENSES**  
**COMPRISING TREATING A PRESELECTED AREA**  
**OF A SINGLE FOCAL LENGTH LENS WITH**  
**IONIZING RADIATION**  
**22 Claims, 2 Drawing Figs.**

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**351/169**

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[50] Field of Search..... **250/49.5**  
**TE, 49.5 GC, 49.5 R, 106 R, 49.5 TC; 65/30**

**ABSTRACT:** A method for obtaining corrective glass lenses which are provided with at least two zones having different powers so that one zone serves to view nearby objects and the other Zone serves to view distant objects wherein, in order to carry out a modification of power in a predetermined region of a corrective lens without entailing any alteration in the shape of said lens, said region is exposed to a radiation flux which results in a modification of its refractive index.

